

# Electrostatic dust remediation for future exploration of the Moon

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## Abstract

Dust accumulation is one of the critical issues that must be mitigated on in-situ lunar explorations because an in-situ probe is exposed to small dust particles, which are easily attached to it, during its operations. The Lunar Dust Science Definition Team is organized by the Jet Propulsion Lab/California Institute of Technology through NASA's Biological and Physical Sciences Division to define key science questions and assess dust remediation techniques. Here, we assess three electrostatic remediation technology concepts: electrostatic dust shield; surface electrostatically collecting dust, later called attractive surface; and electron beam - plasma jet inducing electrostatic dust lofting from a surface. We qualitatively investigate their maturity by defining six operational factors: Time and location; Amount of dust removal; Contamination of target surfaces; Operation duration; Installation; and Safety. In addition to these techniques, we discuss a supporting system that loads dust particles onto a test article to examine dust removal efficiency. The results show that further development increases the maturity of all the technologies. While laboratory and theoretical demonstrations reported whether each technology robustly work on the Moon, which hosts a complex, heterogeneous dust environment, we find that it is still uncertain if this is the case because none has been tested in the lunar environment. Particularly, operation duration and safety are critical to be addressed further on both laboratory and spaceflight scales.

*Keywords:* Space exploration, Lunar surface, In-site operations, Dust physics, Electrostatic charges, Dust mitigation

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# 1 Introduction

## 2 1.1. Risks of dust

3 On the Moon, dust covers a substantial part of its surface. Major dust particles are  
4 generated and sharpened by fragmentation of surface materials during meteoroid impact  
5 events [1]. Volcanic events have also contributed to the generation of dust particles and  
6 the evolution of the surface conditions, particularly within mare [1]. Furthermore, material  
7 mixing frequently occurs due to impacts [e.g., 2], leading to heterogenous dust distributions  
8 from one location to another [e.g., 3]. Because the size of such particles ranges from nm to  
9  $\mu\text{m}$ , they are exposed to various physical forces. For example, during such mixing processes,  
10 gravity and electrostatic forces may cause dust lofting [4].

11 Dust is a contributor to contaminating spacecraft systems both naturally and anthro-  
12 pogenically [5]. Small dust particles can go through narrow parts of the systems, such as  
13 fabric, bearings, and moving parts. Although the Apollo missions in general controlled lu-  
14 nar dust, there are still unresolved issues [6]. For example, suit glove and helmet bearings  
15 experienced no significant effects on operations but had many scratches from dust. While  
16 the lunar rovers had their wheel bearings and electronics sealed against any penetration by  
17 dust, mirrors and thermal control surfaces suffered from dust accumulation and needed to  
18 be cleaned often. Suit visors were usually covered by electrostatically adhering dust, making  
19 dust removal challenging. The dust prevented the sample return containers from maintain-  
20 ing vacuum during storage in the spacecraft. These outcomes indicate that dust mitigation  
21 techniques are still immature and there is a need for further development [6].

22 Dust is also a critical issue for space exploration missions to Mars and airless bodies. On  
23 Mars, dust storms can cover onboard instruments with dust. For example, the Opportunity  
24 rover suffered dust covering on its solar panels, which resulted in mission termination [7].  
25 Recent work studying dust mounting on instruments on the Curiosity rover shows that  
26 vertically mounted instruments experienced less dust covering than horizontally mounted  
27 ones, which possibly results from effective dust removal [8]. Recently, two space exploration  
28 missions explored different rubble pile asteroids. The OSIRIS-REx spacecraft visited 101955  
29 Bennu to sample materials and successfully landed on its surface [9]. On the other hand, the  
30 Hayabusa2 spacecraft explored 162173 Ryugu and obtained samples at two different locations  
31 [10]. However, the Hayabusa2 spacecraft experienced contamination of its remote sensing  
32 instruments by dust particles ejected by chemical thrusters during landing operations. The  
33 attached dust reduced the instrument sensitivity at some levels [11]. Although efforts were  
34 made, none succeeded in removing dust particles from the instruments effectively [11].

## 35 1.2. Dust Mitigation Efforts/Technologies

36 Mitigation technologies can be categorized into passive and active technologies [12]. Pas-  
37 sive technologies are those pre-treated physically or chemically in laboratories to mitigate  
38 dust attraction without using external forces. Active technologies, on the other hand, apply  
39 processes that remove dust on site and can be split into four major steps [13]:

- 40 1. Loosening the dust. This process breaks attractive bonds, which mainly result from  
41 van der Waals/electrostatic forces and hold dust particles on a given surface. Processes  
42 to break them may use mechanical, electrostatic, and chemical effects.

- 43 2. Removing the dust from the surface. This process pulls dust off a surface and can  
44 be achieved by applying mechanical force (e.g., removing dust particles with fluids or  
45 brushes), electrostatic forces, and chemical conditions (solutions to trap dust particles).
- 46 3. Transporting the dust away from the target surface.
- 47 4. Disposing of the dust (properly and safely placing the dust without contaminating  
48 critical areas such as probes and investigation sites).

49 Below, we discuss active technologies using fluid, mechanical, and electrostatic forces.

50 Fluid methods use compressible or incompressible fluids to remove dust from surfaces.  
51 Possible options may include using foams and gels, liquid solutions, and gas solutions [14].  
52 Using fluids, however, may encounter some technical issues, especially in the zero-pressure  
53 environment on the Moon, which may cause immediate evaporation, preventing these so-  
54 lutions from working effectively [14]. On the other hand, experimental jetting tests have  
55 demonstrated that carbon dioxide gas jets might effectively remove dust even in such low-  
56 pressure environments [15]. Gaier et al. [16] used nitrogen gas pulses to quantify whether a  
57 thermally controlled surface enhances the puffs to remove dust; however, given environmental  
58 variations in their study, the results were not advisable.

59 Mechanical methods apply forces driven by equipment (for example, a brush) to remove  
60 dust particles. Reports have generally shown high dust removal performance. The use of  
61 lunar dust samples from the Apollo 12 program demonstrated that brushing (with nylon-  
62 or brass-bristle brush) eased removing dust from various materials [17]. Further analyses  
63 quantified brushing techniques, showing that it achieved high dust removal rates [18, 19].  
64 However, it is also shown that using mechanical brushes usually scratches sensitive, delicate  
65 surfaces [14]. For example, during the Apollo 14 Thermal Degradation Sampling (TDS)  
66 experiments, when astronaut Alan Shepard dusted metal sample holders of the TDS, he  
67 found some brushes scratched the metal samples [20].

68 Electrostatic methods are generally preferred and explored, given the above limitations  
69 for the fluid and mechanical methods. The primary principle is that devices electrostatically  
70 charge dust particles, induce electrostatic forces, and move them from one place to another.  
71 By properly providing dust particles with electrostatic charges, this method can remove them  
72 from a target.

### 73 *1.3. Electrostatic dust remediation technologies and supporting device*

74 We focus on electrostatic dust remediation technologies for removing dust from a target  
75 surface effectively. In this study, we investigate the following three techniques:

- 76 • **Technique A. Electrostatic dust shield:** This technique consists of wires embedded  
77 below a target surface. When an alternating current is passed through the wires, dust  
78 lofting occurs, causing particles to hop off the treated surface. See Figure 1a.
- 79 • **Technique B. Attractive surface:** This is an early phase technology that dust  
80 lofting is prompted by passing an electrically biased plate or wand above a dusty  
81 surface, thereby attracting dust to the biased plate or wand. See Figure 1b.
- 82 • **Technique C. Electron-beam and plasma jets induced lofting:** This technique  
83 combines an electron beam and a plasma jet to enhance the dust removal process. This

84 technique actively charges dust particles electrostatically, enabling dust lofting due to  
85 electrostatic forces and plasma jets. See Figure 1c.

#### 86 1.4. Operational factors

87 To assess the remediation technologies discussed in Section 1.3, we define six operational  
88 factors that would impact the use of them in the lunar environment.

- 89 • **Factor 1. Timing and location:** This factor defines whether the remediation tech-  
90 nique depends on the local time and location. A desired device’s performance is inde-  
91 pendent of the environment. The Moon is rotating with a spin period of around 30  
92 days. The lunar dayside may have an electrostatic potential of 5 V, while the night  
93 side may have -1000 V [21]. Solar energetic electron events could even induce stronger  
94 negative charging on the night side [22]. The variations in the lunar surface charge due  
95 to solar storms, as well as the Moon’s passage through Earth’s magnetotail, may in-  
96 fluence the efficacy of the techniques discussed. The chemical compositions of regolith  
97 may also influence the charge state. The lunar surface mainly consists of two material  
98 conditions; one side is the mare, where volcanic materials are widely distributed, and  
99 the other side is the highlands, where major components consist of light materials.  
100 The mixing of these materials at local levels further makes the problem complex. The  
101 topographic features such as surface roughness control the sunlight condition at local  
102 scales, giving variations in the electrostatic properties. Also, potential sites affected by  
103 the lunar magnetic field may host unique dust particle conditions [23].
- 104 • **Factor 2. Amount of dust removal:** This factor specifies a technique’s dust removal  
105 efficiency. An ideal device is independent of the constraints on the device size and the  
106 amount of dust removal. However, in general, if the technique’s mass increases with  
107 the amount of dust, this factor becomes crucial to constrain the design. For example,  
108 if the method consumes materials, the device mass increases with the scale of dust  
109 removal. Also, if device components are continuously degraded during the operation,  
110 dust removal efficiency eventually becomes lower than the planned threshold.
- 111 • **Factor 3. Contamination of target surfaces:** This factor defines whether the  
112 remediation technique contaminates or damages a target surface. If a target surface  
113 (e.g., camera lenses) is sensitive, it is desirable to keep it clean and unaffected. This  
114 factor is crucial to determine if the considered technique can be applied to desired  
115 purposes regardless of the dust mitigation efficiency.
- 116 • **Factor 4. Operation duration:** This factor defines whether the operation duration  
117 is flexible or limited. A longer operation period (and repeatability) is suitable for the  
118 use of remediation techniques. A technique that can be active as long as a power source  
119 is available is preferable for exploration missions. This factor also accounts for whether  
120 the technique is robust when there is a malfunction of the remediation device.
- 121 • **Factor 5. Installation:** This factor defines how flexibly the remediation technique  
122 can be installed to onboard systems of spacecraft. If the technique is independent of  
123 other onboard systems, it is not necessary to account for potential issues with sys-  
124 tem integrations. When the technique requires a supporting system that needs to be

125 embedded into other onboard systems, such as a target surface, there may be strong  
126 installation constraints.

127 • **Factor 6. Safety:** This factor describes how safely the remediation technique can be  
128 used during operation. The key issues include high electric potentials and UV light,  
129 which may potentially harm astronauts or system hardware. Any dust remediation  
130 technique for impacting spacecraft systems (including humans) negatively should be  
131 avoided.

### 132 1.5. Present scope and outline

133 As the Lunar Dust Science Definition Team established by the Jet Propulsion Lab/California  
134 Institute of Technology through NASA’s Biological and Physical Sciences Division, we assess  
135 the mitigation technology concepts in Section 1.3 to identify remaining questions for them  
136 to be explored in the future. While our assessment is qualitative, this paper summarizes our  
137 findings of necessary development, especially for technology instrumentation for future lunar  
138 landed missions. Our discussions consist of simplified concept designs and assessments of  
139 the remaining elements that need to be developed. The present study is outlined as follows.  
140 Section 2 discusses the Electrostatic Dust Shielding technology (Figure 1a). Section 3 intro-  
141 duces the Attractive Surface technology (Figure 1b). Section 4 shows the UV/Electron-beam  
142 and Plasma Induced Lofting technology (Figure 1c). Section 5 argues the operation factors  
143 that may control the dust remediation efficiency and how each technique is ready to respond  
144 to each factor. In addition, in Section 5, we discuss a dust loading device that mounts dust  
145 on a target surface so that the techniques considered can demonstrate their dust remediation  
146 efficiencies on spaceflight missions (Figure 1d). The present paper is a companion study with  
147 Hartzell et al. [4].

## 148 2. Technique A: Electrostatic dust shield

149 This section discusses the electrostatic dust shield, or Technique A (see Figure 1a). The  
150 fundamental idea of this method is to embed parallel electrodes into a surface and generate  
151 electrodynamic forces controlled by AC signals [25, 26, 27, 28]. This technique consists  
152 of a series of parallel electrodes connected to a two-phase or multi-phase AC voltage that  
153 generates an electric field that oscillates as the polarity of the electrodes changes (Panel a  
154 in Figure 1). This creates a standing wave that produces electrostatic and dielectrophoretic  
155 forces on charged particles in a considered field. These charged particles move either with  
156 or against the wave, depending on polarity. This technique has also been shown to work on  
157 polarizable, uncharged particles [29].

158 Recent applications of this technique demonstrated high performance, giving the recovery  
159 of solar panel power generation to higher than 90% of its nominal condition [e.g., 30, 31, 32].  
160 Manyapu et al. [33] demonstrated an application of this technique, as well as the Work  
161 Function Matching Coating passive technology and the Carbon Nanotube (CNT) flexible  
162 fibers, to remove 80-95% of dust on a spacesuit. This technique’s removal efficiency depends  
163 on both device and dust conditions and properties. For example, the applied amplitude and  
164 frequency of the AC signals influence the removal efficiency [34]. Particle size distributions,  
165 material compositions, and charges also affect dust removal [35]. Higher voltage and vacuum

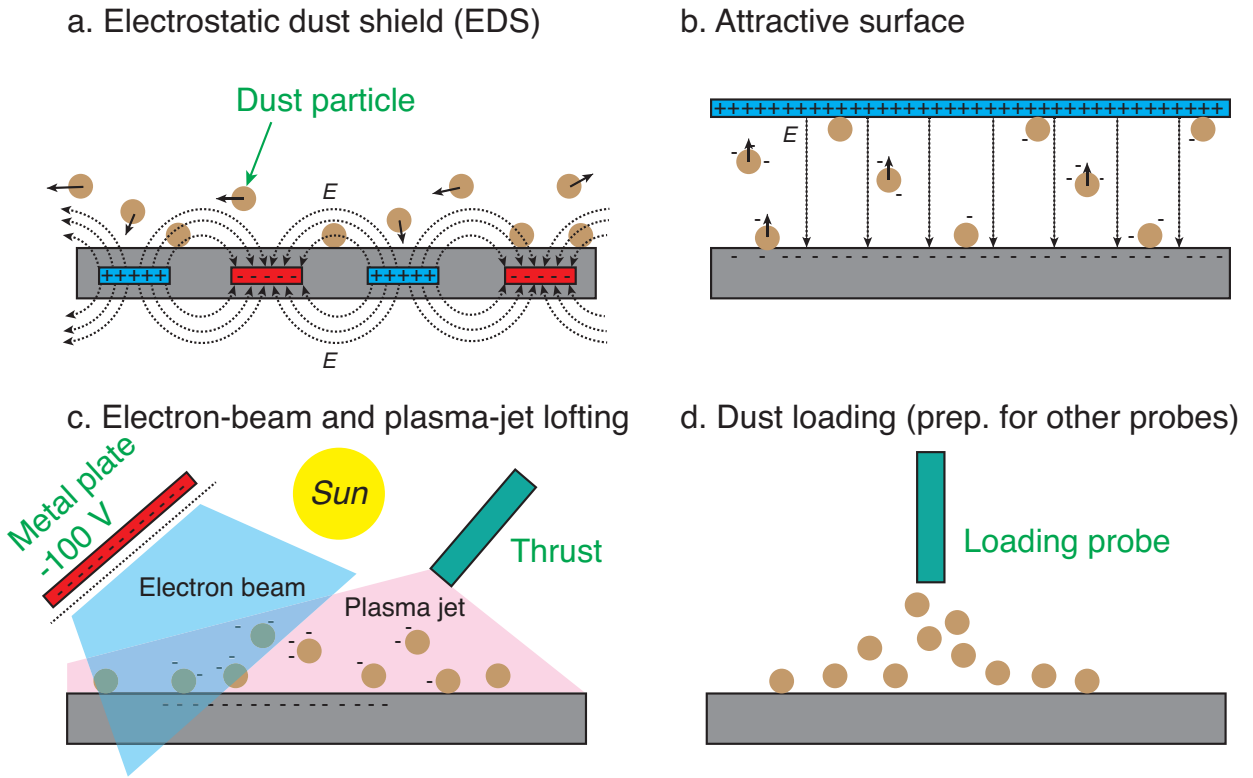


Figure 1: Dust mitigation concepts discussed in this study (a-c) and dust loading concept (d). a. Electrostatic dust shield. The illustration given is based on the 2-Phase electrostatic dust shield design introduced by Buhler et al. [24]. b. Attractive surface. c. Electron-beam and plasma-jet lofting. d. Dust loading device.

166 conditions may give higher dust removal performance [36] because these removal efficiencies  
 167 correlate with the dust particles' hopping processes over an AC-controlled surface [37]. Ap-  
 168 plications to fabric materials (e.g., astronaut spacesuits) also confirmed high dust removal  
 169 with vibrations enhancing the performance [38].

170 The use of this technique on the Earth has also been a key topic, such as cleaning solar  
 171 panels covered by dust [39, 40, 41, 42]. While the mechanisms of these applications are  
 172 similar, techniques behave quite differently in the lunar environment. The main reason is  
 173 the environmental difference between the lunar surface and the Earth surface. First, the  
 174 lunar surface has extremely low humidity compared to the Earth surface. This changes the  
 175 electrostatic dust shield performance [e.g., 43, 44]. Second, on the Moon, the electrostatic  
 176 environment is complex due to the interactions between solar winds and the lunar and Earth  
 177 magnetic fields. This may also be due to variations in material compositions; regions are  
 178 distinguished in mare or highlands [1], but material diversity at local scales has widely been  
 179 reported in the literature [e.g., 45, 46, 47]. While the current version of this technology  
 180 seems partially effective in removing deposited micron-size particles from target surfaces, it  
 181 has not yet been fully tested under realistic lunar surface conditions.

## 182 2.1. Principles

183 We discuss approaches proposed by two groups: Calle et al. [29, 48] and Kawamoto and  
 184 Hashime [49].

185 First, the device tested by Calle et al. [29, 48] includes a two-phase electrode design  
 186 consisting of two sets of parallel copper electrodes interlaced in a comb configuration with  
 187 each set connected to one of the signal inputs which have a 180 degree phase shift. The  
 188 field strength varies proportionally due to the potential difference between the electrodes as  
 189 dictated by the phase shift. Scaled versions include: (a) Transparent 20-cm-diameter elec-  
 190 trostatic dust shield employing indium tin oxide electrodes on a polyethylene terephthalate  
 191 film or (b) Copper electrodes on Kapton film (two with Lotus coating).

192 Successful demonstrations of a two-dimensional (2D) version of this electrostatic dust  
 193 shield system have been reported in the literature on (1) solar panels [29, 32], (2) optical  
 194 systems [32, 50], (3) viewports [48], (4) thermal radiators (for both AZ-93 thermal paint  
 195 and Fluoro Ethylene Polypropylene coatings) [32], (5) spacesuit fabric (Mars and Lunar  
 196 environments), and (6) both the Pressurized Excursion Module and the Lunar Habitat  
 197 Demonstration Unit [48]. Also, the production process has recently been updated to ap-  
 198 ply photo-lithography which allows the production of larger panels with fewer defects at an  
 199 increased production rate [50]. Solar panel dust clearing results to date show approximately  
 200 up to 98 percent dust clearing after 30 minutes while this value was about 96% for ther-  
 201 mal radiators [29, 32]. Buhler et al. [24] developed a three-dimensional (3D) version of the  
 202 electrostatic dust shield.

203 Second, Kawamoto and Hashime [49] developed a similar system that uses a four-phase  
 204 rectangular voltage and also showed that the cleaning process is improved by application of  
 205 ultrasonic vibrations. This approach, allowing both positively and negatively charged dust  
 206 particles to be cleared without changing the configuration of the system, has been tested  
 207 using the lunar dust brought back by Apollo 11. Numerical models suggest that the cleaning  
 208 performance of this technique should improve in the gravitational environment of the Moon.  
 209 The system reportedly has no moving mechanical parts and consumes less power than the  
 210 electrostatic dust shield by Calle et al. [29, 48].

## 211 *2.2. Concept study for spaceflight*

212 Here, we summarize the currently available size, mass, and power of the electrostatic  
 213 dust shield system by referring to Kawamoto and Guo [49]. Their device consists of two  
 214 components: a high voltage source and an electrostatic dust shield cleaner plate. That total  
 215 mass is 210 g (180 g for the high voltage source and 30 g for the cleaner plate) and the  
 216 required potential is  $\pm 6$  kV (Table 1). The dimensions and used products are provided in  
 217 Table 2. While the generated potential is up to 1 kV, the reported power is 0.5 W during  
 218 operations and 0.3 W in the idling mode [49]. This specification promises the feasibility of  
 219 this device for future spaceflight.

Table 1: Specification of the electrostatic dust shield system developed by Kawamoto and Guo [49].

	Mass (g)	Potential (V)
High Voltage Source	180	Positive/Negative 1 kV
Cleaner Plate	30	N/A

Table 2: Dimensions of the cleaner plate and electrodes as well as the substrate and amplifiers developed by Kawamoto and Guo [49].

	Dimensions (mm)
Prototype High Voltage Source	125(L) x 70(W) x 40(H)
Cleaner Plate	100(L) x 100(W) x 1.1(T)
Width and Pitch of Electrodes	0.3 / 0.6
Substrate	Borosilicate Glass
Substrate Covering	Borosilicate Glass (0.1)
Positive / Negative Amplifiers	Matsusada Precision - HVBT-1P-5 and 1N-5
Amplifiers Switching	Panasonic AQV258

220 *2.3. Suggested areas of technology advancement*

221 While the electrostatic dust shield technology has already demonstrated several promising  
 222 outcomes, it requires further advancement to be flown. We summarize the areas needing  
 223 technology development below.

- 224 • Further investigation of the scaling of these devices to larger surface areas is necessary.  
 225 Tests to date have considered a small active area. Operational methods and efficiencies  
 226 for larger active areas are currently unexplored.
- 227 • Power sources need to be optimized to ensure minimum size, weight and power con-  
 228 sumption.
- 229 • Current systems still require testing at both the maximum and minimum temperatures  
 230 observed in the lunar environment.
- 231 • The lunar plasma environment is complex under interactions with the Earth’s magne-  
 232 tosphere, but the mechanism is poorly understood. Future assessment is necessary to  
 233 make sure this technique robustly works on the Moon.

234 **3. Technique B: Attractive surface**

235 This section illustrates the attractive surface technique, or Technique B. This technique  
 236 uses an electrically charged plate to attract charged dust particles and remove them from  
 237 target surfaces. Dust particles are naturally electrically charged due to solar wind impinge-  
 238 ment, photoemission, and tribocharging. The electrostatic force produced by a charged plate  
 239 can cause the dust to detach from surfaces. The addition of electrostatic charges to the plate  
 240 induces a stronger electric field, enhancing the magnitude of the electrostatic forces acting  
 241 on dust particles exposed to it. A series of dust hops can be used to electrostatically sweep  
 242 dust off a surface, given fringing fields at the edges of the plate. We neglect the plasma envi-  
 243 ronment near the lunar surface in our preliminary calculation, assuming that the attractor is  
 244 within the Debye sheath of the dust-bearing surface ( $\sim 1$  m in the lunar environment [e.g.,  
 245 4]).



246 *3.1. Principles*

247 To assess the efficiency of this technique, we compare the magnitude of forces acting  
 248 on dust particles adhered to a plate. The main forces include the gravitational force, the  
 249 attractive force that binds surface particles together, and the electrostatic force acting on the  
 250 charged dust particles. The necessary condition to electrically remove dust particles from  
 251 a surface is that an electrostatic force acting on a dust particle exceeds gravity and forces  
 252 binding the dust particle to a dusty surface:

$$F_{es} > F_{grav} + F_{co} \quad (1)$$

253 where  $F_{es}$  is the electrostatic force driven by the attractor plate ( $F_{es} = Q\Delta\phi/\Delta h$ , where  $Q$   
 254 is the charge of the dust grain,  $\Delta h$  is the height of the attractor above the surface, and  $\Delta\phi$  is  
 255 the potential between the attractor and the target surface),  $F_{grav}$  is the gravitational force,  
 256 and  $F_{co}$  is the force binding dust particles.

257 The above condition yields the electric potential of the attractor required to cause dust  
 258 motion. We assume that the dust grains are spherical, with a material density of  $2 \text{ g/cm}^3$ , and  
 259 that the lunar surface gravity is  $1.625 \text{ m/s}^2$ . We characterize the cohesive force,  $F_{co} = \sigma_{co}\pi r_d^2$ ,  
 260 where  $\sigma_{co}$  is the cohesive strength in Pa, and  $r_d$  is the radius of the dust grain. Substituting  
 261 the definitions of the forces into Equation (1) gives:

$$Q\Delta\phi/\Delta h > 4/3\pi r_d^3 \rho g + \sigma_{co}\pi r_d^2 \quad (2)$$

262 We consider  $\Delta h = 10 \text{ cm}$ , although this can be varied. The attractor must remain close to  
 263 the surface ( $< 30 \text{ cm}$ ) for the shield due to the near-surface plasma being negligible. Figure 2  
 264 shows predictions of the electric potential of the attractor required to cause particles lofting  
 265 for a range of cohesive strengths and grain potentials. While lunar dust may be referred  
 266 to as those less than  $20 \mu\text{m}$  in size, the present analysis shows a broader range of lunar  
 267 particle sizes to quantify the general trends. The grain charge is modeled using a spherical  
 268 capacitor approach, which gives  $Q = 4\pi\epsilon_0 r_d V$ , where  $V$  is the grain potential, and  $\epsilon_0$  is the  
 269 permittivity of free space.

270 While the amount and polarity of the charge on individual dust grains are not constrained,  
 271 grains can be charged due to interactions with the solar wind plasma, UV-induced photoe-  
 272 mission and tribocharging. Prior experimental work by Schwan et al. [51] has shown that  
 273 electron emission can result in charges up to 10's of thousands of electrons for 40 micron-scale  
 274 grains. Additionally, Carter and Hartzell [52] have shown that 200 micron-scale tribocharged  
 275 silica-zirconia beads can support charges up to millions of electrons.

276 *3.2. Concept study for spaceflight*

277 To approximate the size, mass, and power requirements of the dust attractor device, we  
 278 assume a hand-held plate-type attractor sized to be used by astronauts and robotic devices.  
 279 This type of attractor should not be larger than 30 cm in size. Larger attractor plates require  
 280 more power to operate, as increased surface area enables increased current to the plate from  
 281 the ambient plasma. To calculate the mass of the attractor plate, we consider it to be made  
 282 of aluminum (with a density of  $2.7 \text{ g/cm}^3$ ). We estimate the power ( $P$ ) required to hold the  
 283 plate at the required electric potential from:

$$P = I\Delta\phi \quad (3)$$

$$I = n_e A_{plate} e V T_e \quad (4)$$

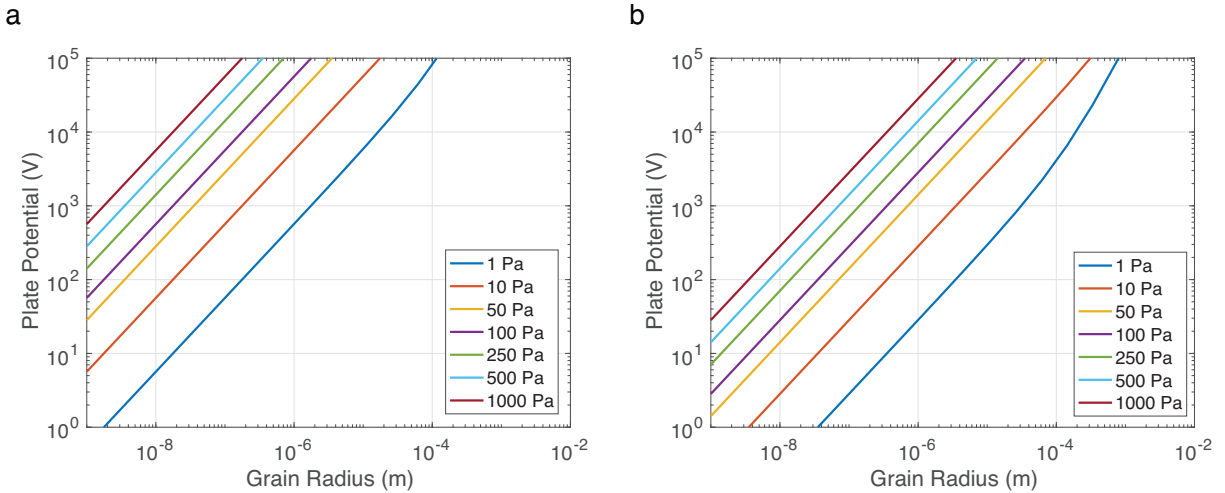


Figure 2: Electric potential of the attractor required to electrostatically loft dust with varying grain electric potential and cohesive strength. Panel a assumes a grain potential of 5 V, while Panel b illustrates results for 100 V. The legends in both panels show  $\sigma_{co}$ . The grain radius range is defined based on the particle size distribution in the Apollo samples [1].

284 where  $I$  is the electric current,  $n_e$  is the local plasma density (assumed to be  $2.5 \times 10^6$   
 285  $\text{m}^{-3}$ , half of the freestream ion density due to the local plasma sheath),  $A_{plate}$  is the cross  
 286 sectional area of the plate,  $e$  is the charge of an electron, and  $v_{Te}$  is the thermal velocity of  
 287 the electrons.  $n_e$  can range widely, depending on the lunar surface conditions, and is not  
 288 well constrained. For example, Popel et al. [53] considered  $n_e$  to be  $8.3 \times 10^6 \text{ m}^{-3}$ . The use  
 289 of  $n_e = 2.5 \times 10^6 \text{ m}^{-3}$  only provides a rough idea of this approach, and thus further analyses  
 290 are necessary. Assuming an electron temperature of 15 eV, this zeroth order approximation  
 291 leads to a required power of 8 mW for a  $30 \text{ cm} \times 30 \text{ cm}$  plate biased to  $10^5 \text{ V}$  (Table 3).  
 292 Because the plate potential must remain constant (i.e., its functionality is based on its use  
 293 at a potential not equal to the floating potential), the current to the plate from the local  
 294 plasma environment must be balanced by a power supply attached to the plate. While 8  
 295 mW is a relatively small steady-state power draw, we note that this power evaluation does  
 296 not account for the fact that the plate is at a high potential, and thus the current can be  
 297 much larger than the thermal current.

298 The major operational constraint is that the dust must be charged to be affected by the  
 299 dust attractor. Regolith on both the day and night is expected to be charged. However,  
 300 charging may be quicker on the day-side, due to photoemission and the increased plasma  
 301 density (as compared to the wake region on the nightside). It is possible that the dust  
 302 attractor's performance will be enhanced by certain astronaut activities. Tribocharging of  
 303 the substrate (e.g, astronaut or spacecraft) to which the dust adheres may influence the  
 304 plasma environment near the surface, and, in turn, influence the nominal charge of the  
 305 grains [54]. Additionally, changing the orientation of the dust covered surface with respect  
 306 to the solar incidence angle may change the charge of the grains – a property that may be  
 307 exploited during operations.

### 308 3.3. Suggested areas of technology advancement

309 Below is a list of necessary advancements for this technique.

Table 3: Estimated requirements for a dust attractor plate.

	Dimensions (cm)	Mass (g)	Power (W)
Attractor Plate	$30 \times 30 \times 0.5$	1,215	8 mW (baseline)

- 310 • The attractive surface format should be optimized. Fringing fields may be particu-  
 311 larly effective at moving particles, which would suggest that a wand format may be  
 312 more effective for remediation. However, because of the decreased size of the wand  
 313 as compared to a plate, the wand may be more easily shielded by the near-surface  
 314 plasma, thus requiring either higher voltages or positioning of the wand closer to the  
 315 dust-covered surface. In contrast, a plate may more quickly remove dust from a larger  
 316 area.
- 317 • The effect of operational changes such as different target surfaces and timing should  
 318 be investigated to determine whether or not these significantly influence the efficacy of  
 319 the device.
- 320 • Experiments are needed to quantify the efficacy of removing dust from a surface in the  
 321 lunar environment.

#### 322 4. Technique C: Electron-beam and plasma jet induced lofting

323 This section discusses a combination of plasma jets and electron beams to perform dust  
 324 remediation (Figure 2c). This technology’s uniqueness is to move dust by using plasma jets  
 325 and enhance its performance by actively supplying electrostatic charges to dust particles  
 326 using solar UV light.

##### 327 4.1. Principle

328 Technique C may offer two versions. The first version combines an electron beam and a  
 329 weak plasma, while the second version has plasma only but with higher density than in the  
 330 first version. The first version exploits sunlight-instigated natural photo-emission to create  
 331 the electron beam. Below, we introduce the principles of generating electron beams and  
 332 plasma jets.

##### 333 4.1.1. Electron beams

334 Flanagan and Goree [55] generated a 70-eV electron beam in a setup where a hot tungsten  
 335 filament was used in conjunction with an applied 70 V bias with respect to ground walls. The  
 336 resulting thermal electrons are characterized by two Maxwellian populations, one colder with  
 337 temperature  $T_{cold} \sim 0.3\text{-}4$  eV and one hotter with temperature 3-16 eV. The density could be  
 338 varied between  $2.4 \times 10^6 \text{ cm}^{-3}$  and  $2.5 \times 10^8 \text{ cm}^{-3}$ . A 4.5 cm diameter glass sphere was coated  
 339 with JSC-1 lunar dust simulat, with dust size distribution having a characteristic size less  
 340 than  $20 \mu\text{m}$ . The coated sample was then exposed to the thermal plasma or the electron  
 341 beam or both. There are three key findings from Flanagan and Goree [55]. First, measurable  
 342 dust release could only be obtained when the sample was exposed to both the thermal plasma  
 343 and the electron beam. Second, significant dust release occurred only for plasma densities  
 344 above  $2.4 \times 10^6 \text{ cm}^{-3}$ , suggesting a density threshold for strong dust mobilization. Last, the

345 release time-dependence followed an exponential decay with a release rate between 4 s and  
346 25 s, with faster release rates associated with higher plasma densities.

347 Another set of experiments with similar conditions was performed by Schwan et al. [51].  
348 In their experiments, the beam emitted by a hot filament had an energy of 120 eV. The  
349 thermal electron temperature was reported to be  $\sim 2$  eV [51], although no measurements of  
350 the plasma density were provided. Schwan et al. [51] confirmed the findings by Flanagan  
351 and Goree [55], who showed that dust could be mobilized when exposed to a plasma and an  
352 electron beam. Their focus may be slightly different from our interest in applying a combina-  
353 tion of electron beams and plasma jets because they attempted to demonstrate the so-called  
354 ‘Patched Charge Model,’ which suggests that dust is mobilized by strong electrostatic forces  
355 building up in microcavities.

356 Farr et al. [56] later used a  $1.5 \mu\text{A cm}^{-2}$ , 230 eV electron beam on a dust-coated flat  
357 target glass to observe dust shedding from the surface. The lofting of dust particles is mainly  
358 considered to result from secondary electrons that are created on the dusty surface exposed  
359 to the beam and become absorbed into microcavities between the dust grains. This process  
360 charges the dust grains negatively, causing them to repel each other and to be ejected from  
361 the surface.

#### 362 4.1.2. Plasma jets

363 Ticos et al. [57] reported a technique for using plasma jets to clean surfaces, which they  
364 called the plasma broom technique. The reported plasma broom used a plasma jet produced  
365 in a pulsed discharge (pulse length of  $\sim 1 \mu\text{s}$ ). The setup by Ticos et al. [57] was based on  
366 a coaxial plasma gun with the gap filled by CO<sub>2</sub> gas with pressure of 670 Pa and an applied  
367 voltage between 1 kV and 2 kV. This plasma jet technique was applied to the cleanup of  
368 solar panels coated by a thick layer of JSC-1 martian simulant dust. During the operation  
369 of this technique, the plasma densities were extremely high, of the order of  $10^{21} \text{ m}^{-3}$ , and  
370 the dust particles were expelled from the surface simply by drag forces. Ticos et al. [57]  
371 demonstrated a high cleaning efficiency of  $> 97\%$  after only a few shots at 2 kV voltage, and  
372 an energy consumption of about 250 J per pulse. The application of this technique to the  
373 lunar environment may be challenging because additional adjustments may be necessary to  
374 provide the required conditions; for instance, there may need to either (i) have a gas source  
375 that would puff in a cloud of 670 Pa gas just before the pulse or (ii) have a solid ablated by  
376 an arc to provide the mass for the plasma.

#### 377 4.2. Concept study for spaceflight

378 Considering the first version of this technique, we propose an alternative approach that  
379 uses both electron beams (Section 4.1.1) and plasma jets (Section 4.1.2). This approach com-  
380 bines plasma jets and electron beams without the need for a hot filament providing electrons  
381 and a gas supply for the plasma mass. Electron beams are sourced by naturally provided  
382 photoelectrons (solar UV), and plasma jets come from another source. The proposed setup  
383 is sketched in Figure 3. The specification of this apparatus is provided in Table 4. The  
384 influence of the lunar plasma environment on this device concept may need to be quantified;  
385 however, it is likely negligible because the plasma density for this device may be as high  
386 as  $10^{21} \text{ m}^{-3}$ , while that in the lunar environment only may only reach  $10^6 \text{ m}^{-3}$  with large  
387 uncertainties, as discussed above.

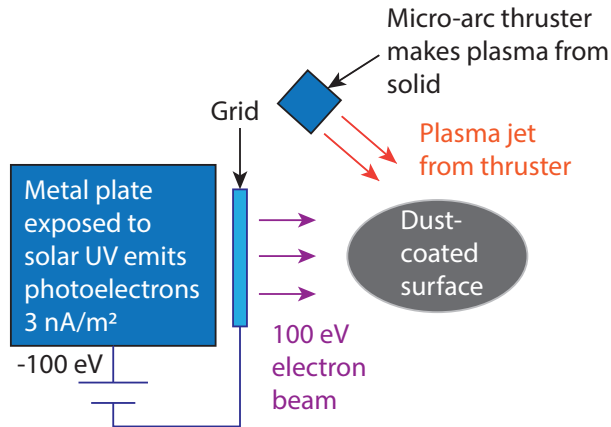


Figure 3: Sketch of proposed dust remediation scheme. This scheme is inspired by [55], who applied plasma and electron beams to enhance particle release. An electron beam created from accelerated photoelectrons is aimed at the region to be cleaned. This region is also sprayed with low density plasma coming from a continuously operating vacuum arc thruster.

388 Electron beams are generated by using a metal plate with nominal dimensions of 30 cm  
 389  $\times$  30 cm exposed to sunlight so that the plate emits photoelectrons. The plate is biased  
 390 to -100 V so that the photoelectrons are ejected with 100 eV energy. A nearly transparent  
 391 grid biased to 0 V is located just above the metal plate. Electrons are accelerated towards  
 392 the grid but, because of the grid transparency, continue through the grid to form a beam.  
 393 This process generates a directed 100 eV electron beam without the use of hot filaments.  
 394 The electron beam is directed at the dusty surface to be cleaned. Assuming 3 nA/cm<sup>2</sup>  
 395 photoemission as typical for space materials [58], a current of 3  $\mu$ A is supplied from the  
 396 metal plate.

397 A plasma micro-thruster is used to generate a continuous plasma jet. Microthrusters  
 398 have widely been tested with emphasis placed on thrust, efficiency, and longevity, while  
 399 there has also been first-principle modeling [e.g., 59]. This type of thruster is intended  
 400 for small satellites such as CubeSats and so does not consume much power [60]. In this  
 401 thruster, plasma is made from a solid material, and so no gas supply is needed. Two possible  
 402 options are the vacuum arc thruster [61] and the Polytetrafluoroethylene (PTFE, known as  
 403 Teflon) thruster [62, 63]. These small, light-weight, low-power thrusters are intended for  
 404 quasi-continuous operation and provide a directed plasma jet. The vacuum arc thruster  
 405 typically has a coaxial cathode (inner conductor) and anode (outer conductor) with vacuum  
 406 in between. High voltage breaks down the anode-cathode gap and melts small quantities of  
 407 cathode, which become plasma. The background is essentially vacuum so the plasma is fully  
 408 ionized. Electromagnetic forces accelerate the plasma to produce a jet with velocity of tens  
 409 of km/s.

410 On the other hand, the Teflon thruster ablates Teflon located between the cathode and  
 411 anode to make a weakly ionized plasma from the ablated Teflon. A combination of thermal  
 412 pressure gradient and electromagnetic forces accelerates the Teflon plasma out to form a  
 413 jet. Depending on the design, the exhaust velocity of the Teflon thruster can range from  $\sim$ 2  
 414 km/s to 50 km/s [62]. It has capacitor discharges lasting several  $\mu$ s, stored energy of tens of

415 Joules, and pulse repetition rate of 1 Hz [62]. The Teflon thruster differs from the plasma  
 416 broom as the plasma broom involves a very high power transient pulse (order 1  $\mu$ s) and  
 417 would be fired using a large capacitor that is slowly charged and then quickly discharged.

Table 4: Categorization of microthrusters. We referred to Burton [62] for the pulsed plasma thruster and Kolbeck and Anders [61] for the vacuum arc thruster. \*Values for the LES-8/9 PPT thruster, given in Table 2 in Burton [62]. \*\*Values based on the thruster planned for the Illinois Observing Nanosatellite (ION), a 2U CubeSat from the University of Illinois at Urbana-Champaign [61].

		Pulsed plasma thruster	Vacuum arc thruster	
		Value	Value	Units
Operation	Mass	6.60*	0.15**	[kg]
	Pulse length	$\sim 20$	$> 250$	[ $\mu$ s]
	Power	$\sim 100$	0.1 – 20	W
	Repetition rate	1	1	[Hz]
Propellant		Teflon	Aluminum**	[-]
Plasma	Ionization	10 – 40	100	[%]
	Electron density	$10^{16}$	$10^{14}$	[ $\text{cm}^{-3}$ ]
	Exhaust velocity	10 – 50	20 – 40	[km/s]

#### 418 4.3. Suggested areas of technology advancement

419 We list necessary technology advancements below:

- 420 • The electron beam source using sunlight generates an electric current likely 3-4 orders  
 421 of magnitude smaller than that used by Flanagan and Goree [55] and Schwan et al.  
 422 [51]. This discrepancy can be reasonable because it only lengthens the exposure time  
 423 for dust removal from seconds to hours and thus does not affect operations on the  
 424 Moon. However, proper assessments are necessary.
- 425 • The dust removal efficiency of this technique has not been demonstrated well yet.  
 426 It is necessary to conduct lab experiments using various types of microthrusters to  
 427 determine whether high plasma momentum is critical or whether simple presence of  
 428 low momentum plasma is sufficient when used with an electron beam.
- 429 • The plasma jets may contaminate sensitive surfaces. If this is the case, it is necessary  
 430 to quantify how the plasma jets influence the surface conditions to reduce this risk.

## 431 5. Discussion

### 432 5.1. Dust mitigation performance

433 Based on the operational factors defined in the previous section, we assess the technology  
 434 of each technique. Table 5 summarizes the rates for each technology. In this table, three cat-  
 435 egories  $\circ$ ,  $\triangle$ , and  $\times$  mean that a considered factor is well characterized, less characterized,  
 436 and not explored, respectively. If Sections 2 through 4 identify multiple studies to address  
 437 a considered factor, we consider it to be well characterized. If there is limited work, and we

Table 5: Operational factor rates of each technology. The top row specifies techniques: A, Electrostatic dust shield; B, Attractive surface; C, Electron-beam, and plasma induced lofting. The first column shows the operational factors.  $\circ$ ,  $\triangle$ , and  $\times$  indicate the applicability levels, meaning *well characterized*, *less characterized*, and *not explored*, respectively.

	A	B	C
1. Location & timing	$\triangle$	$\triangle$	$\triangle$
2. Amount of dust removal	$\circ$	$\times$	$\triangle$
3. Contamination	$\circ$	$\circ$	$\times$
4. Operation duration	$\times$	$\times$	$\triangle$
5. Installation	$\times$	$\circ$	$\circ$
6. Safety	$\triangle$	$\times$	$\times$

438 identify the need for additional investigations, we label it as less characterized. Finally, if  
 439 we find necessary technologies (or processes), but there is no report discussing the factor, we  
 440 define it as not explored. Overall, while each technology shows strong advantages, it needs  
 441 additional investigations to mature.

442 *5.1.1. Technique A: Electrostatic dust shield*

443 This technique has been demonstrated in multiple studies, showing the highest maturity  
 444 among the considered techniques. This technique continuously removes accumulated dust on  
 445 a test surface as long as the device is active. This technique needs further investigations of  
 446 the performance in the lunar environment, where dust’s electrostatic properties likely change  
 447 over time and location. The amount of dust removal was well characterized by earlier work.  
 448 We identify no issues on the contamination of the target surface but consider some issues on  
 449 the operational duration factor due to the necessity of its robust design. For example, if the  
 450 device is embedded in other systems like spacecraft surfaces, a single cut of its electric circuit  
 451 may lead to the termination of operation because there may be no way of replacing it. A  
 452 possible mitigation of this issue may be to design backup systems. Also, for the installation  
 453 factor, the flexibility of incorporating the dust shield into complex geometric components  
 454 may be limited. Additive manufacturing may be a potential solution to this issue, although  
 455 complex electrostatic force fields, possibly reducing the dust removal efficiency, may need  
 456 to be quantified. Regarding the safety factor, Buhler et al. [24] demonstrated that the  
 457 3D version of the Electrodynamics Dust Shields developed a safe zone that prohibits the  
 458 penetration of large electromagnetic fields. Therefore, we find that resolving this issue is in  
 459 progress, and this factor is currently under investigation.

460 *5.1.2. Technique B: Attractive surface*

461 The performance of this technique is likely affected by the location and timing, i.e., the  
 462 dust particle conditions in the lunar surface environment. How such variations control the  
 463 dust remediation efficiency needs to be quantified. Also, how much dust it can remove is  
 464 currently unknown. No contamination is expected for this technique. The operation duration  
 465 needs to be quantified especially because the dust removal efficiency may change with time  
 466 due to the attachment of dust particles to the attractive surface. This technique does not

467 need to be incorporated into a target surface, i.e., no constraints on the installation factor.  
468 This trend allows users to apply this technique directly without any design changes in other  
469 systems. However, it may be necessary to bring the attractive surface close to a target  
470 surface that is hardly approachable. A key safety issue includes a high electric potential  
471 between the attractive plate and the target surface, which may increase the possibility of  
472 harming the system hardware and astronauts.

### 473 *5.1.3. Technique C: Electron-beam and plasma jet induced lofting*

474 Technique C uniquely uses electron beams and plasma jets to remove dust particles from  
475 a target surface. Again, electron beams are used to electrostatically charge dust particles,  
476 while plasma jets are applied to kinetically move dust particles. This technique enhances  
477 the mobility of dust particles. It can choose whether electron beams are necessary; even  
478 when electron beams are not available, plasma jets can still be used. Therefore, we consider  
479 this technique to perform at any location and timing, though it is necessary to quantify how  
480 this factor changes the performance. While Ticos et al. [57] reported a high efficiency of  
481 the plasma broom, it is still necessary to quantify its performance in various space environ-  
482 ments. The contamination of a target surface may need to be quantified. Given the process  
483 considered, plasma jets generated by melting the cathode may affect the target surface. If  
484 the target surface is sensitive, like remote sensing instruments and other onboard systems,  
485 it is necessary to have proper mitigation processes. Also, because this technique consumes  
486 the cathode, the operation duration may be limited. Because this mitigation system is in-  
487 dependent of other onboard systems, no interactions between them need to be considered.  
488 Regarding the safety issue, it is necessary to assess how electron beams and plasma jets affect  
489 the onboard systems and astronauts.

### 490 *5.2. Dust loading device*

491 This section discusses a dust loading device that can be used to load dust onto a coupon  
492 to test the efficacy of various remediation technologies (Figure 2d). The device is used  
493 for remediation technology demonstration. Once the remediation technology is established,  
494 the loading device is no longer necessary. The major purpose of this dust loading device  
495 is to quantify how efficiently each dust mitigation technique removes dust from a testbed.  
496 How much dust is naturally accumulated on the lunar surface is poorly understood and  
497 also strongly depends on the location. This issue likely challenges quantitative assessment.  
498 Cohesion/adhesion likely affects the efficiency of the sorting process using sieving. How-  
499 ever, agitation is anticipated to break particle-particle/particle-surface interactions, leading  
500 to granular particle fluidization. Another concern may be how lower gravity affects this  
501 process; however, recent studies have shown higher fluidization in microgravity [64], giving  
502 the possibility that the lunar environment may be preferred for the dust sorting process  
503 compared to the Earth environment, regardless of the necessity of further investigation.

504 In this study, we assume that the dust samples are loaded onto the loading device by  
505 either a robotic device or an astronaut. Based on the Apollo lunar samples [1], we consider  
506 that target particles are tens of microns in size, and the necessary amount for one loading  
507 is small. Following the styles of Sections 2 through 4, we describe the device's principle,  
508 concept study for spaceflight, and suggested areas of technology advancement.



### 509 5.2.1. Principle

510 The main purpose of this device is to support loading dust particles on testbeds for  
511 experiments. While the probe's size may depend on the testbeds, we assume that the testbeds  
512 are a few cm in diameter. If the probe's size needs to be modified, proper resizing is still  
513 possible. Our straw-man design consists of three components: an electric agitator, sieves,  
514 and a glass funnel (Figure 4). An electric agitator will be used to help sort out dust particles  
515 by vibration in a vacuum.

516 Sieves are used to sort dust particles by size. There are commercially available sieves  
517 that sort out dust particles in this size range (down to 20  $\mu\text{m}$ ). A glass funnel is used to  
518 load the sorted dust particles on the testbeds. The funnel's internal diameter needs to be  
519 determined to avoid clogging based on the size of the testbeds and the necessary amount of  
520 dust particles. The solution to this issue may be to control the dust flow rate and design an  
521 appropriately sized funnel. Challenges may appear when we target smaller dust particles.  
522 The cohesive/adhesive forces influence small particles – thus, it is more difficult to predict  
523 the flow rate for small dust particles. Particularly, if electrostatic charges are added to the  
524 probe during operations, electrostatic forces enhance such forces. While using electrically  
525 insulated materials may be a possible solution, this issue needs to be resolved. However,  
526 cohesion-based clumps were observed to be a few mm in size from lunar dust observations  
527 on the Apollo mission [65]. For our target (lunar surface layers having particles with sizes  
528 of  $\sim \mu\text{m}$ ), we consider that a funnel size larger than 1 cm would avoid this issue.

529 Figure 4 shows a schematic of the device seen from the side view and the top view.  
530 An electric agitator and sieves are fixed on a movable base. Multiple sieves with different  
531 mesh sizes are placed to make the sorting efficient (to prevent clogging). Once the agitator  
532 is on, the vibration allows dust particles to be granularly fluidized. Smaller particles can  
533 go through the mesh of Sieve 1. As they reach other sieves, the mesh sizes become finer.  
534 When dust particles pass through Sieve 4, they enter the glass funnel. The movable base  
535 is connected with the fixed base by vibration isolation pads that absorb the movable base's  
536 vibration. The fixed base can be connected with other hardware devices. Beneath the fixed  
537 base, a connector is placed to connect the fixed base and the glass funnel. The movable base,  
538 the fixed base, and the connector have wide holes so that dust particles sorted by the sieves  
539 can go through the system.

### 540 5.2.2. Concept study for spaceflight

541 To demonstrate the feasibility of the dust loading device, we need to show the availability  
542 of an electronic agitator. However, we could not find a space qualified product. Here, we  
543 use the Micro Series Electric Vibrators available by Martin Vibration Systems & Solutions  
544 [66] as a sample device. However, the specification of an agitator necessary for our mission  
545 should be similar to the cited product. Considering the NEA 504 series [66], we confirm  
546 that the agitator's size is as small as 0.1 m by 0.1 m by 0.1 m. The power input is around  
547  $\sim 30$  W. The maximum force is 260 N. The vibrator's operating temperature range is 273  
548 K - 310 K; therefore, thermal control is likely necessary. The process of shaking particles  
549 in sieves has been used in many terrestrial industries. However, the necessary devices and  
550 subsystems may not have been used or tested in the space environment. Considering two  
551 aluminum plates (0.3 m by 0.3 m by 0.005 m for each) for the bases, we estimate the device  
552 mass as  $\sim 5$  kg.

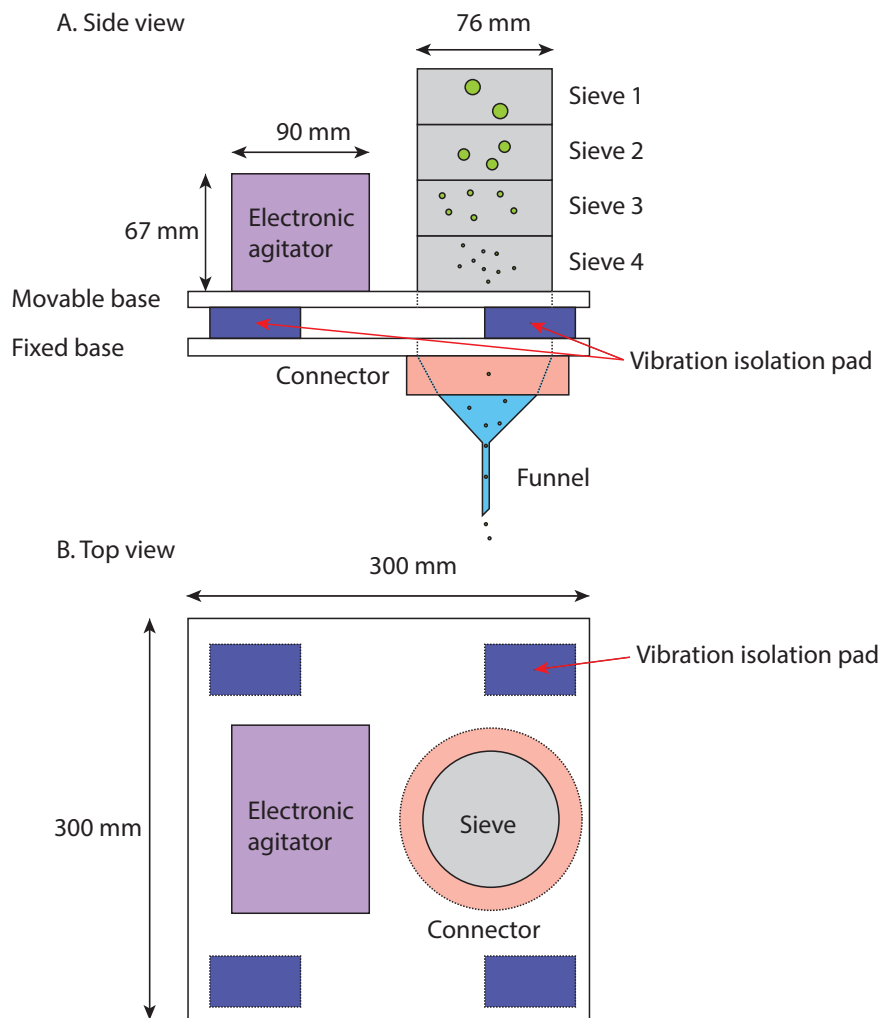


Figure 4: Schematic of dust loading device

Table 6: Estimated requirements for dust loading device.

Properties	Value	Units
Dimensions	$30 \times 30 \times 10.5$	[cm×cm×cm]
Mass	5	[kg]
Power	30	[W]
Temperature	273 – 310	[K]

553 *5.2.3. Suggested areas of technology advancement*

554 Below are potential issues to be mitigated.

- 555 • The sieving process in the lunar environment needs to be investigated to ensure the  
556 efficiency of the dust loading device. Particularly, the current sieving portion is a  
557 tentative solution, as there may be a risk that low gravity on the Moon may cause an  
558 enhanced influence of adhesive and cohesive forces on particles and the sieving grids.  
559 An alternative solution is necessary if low gravity tests are not conclusive for efficient  
560 particle flow through the sieve setup.
- 561 • The way of loading dust particles to the device (i.e., how to put dust particles into  
562 Sieve 1) needs to be specified. A possible design for this operation is using a scoop or  
563 a drilling system. However, for the use of a robotic system, it is likely that such an  
564 operation can draw heavily from the work of the Mars rovers.
- 565 • While we illustrated four sieves, it is unknown how many sieves are necessary. This  
566 depends on the desired particle sizes. However, adding additional sieves does not dra-  
567 matically change the design (other than increasing the mass and changing the vibration  
568 frequency of the system).
- 569 • There is no active device that controls the amount of dust falling into the glass funnel.  
570 The main contributor to preventing granular flows of dust particles is cohesion and  
571 friction. If the funnel is sized close to the jamming limit (at which point the grains  
572 would clog the funnel and the flow would stop), changing the level of agitation may be  
573 able to control the amount of grains deposited on the desired coupon.
- 574 • As the device continues to sort out dust particles, particles that cannot go through  
575 the sieves are stuck and thus accumulated there. The easiest way may be that the  
576 loading device is just one-time use. The planned loading device can likely supply dust  
577 more than necessary for experiments and does not need to clean the sieves. If repeated  
578 cleaning processes are required, sophisticated mechanical systems are inevitable, which  
579 is out of our scope.
- 580 • Further concept design to reduce this device’s size and mass is essential to make it fit  
581 future exploration missions.

582 **6. Conclusion**

583 This paper discussed three electrostatic dust remediation techniques for lunar exploration  
584 missions. We assessed electrostatic dust shielding, an attractive surface, and electron beams

585 and plasma jets inducing dust lofting. We defined six operational factors to assess these  
586 techniques and necessary development to be completed. The operational factors included  
587 the timing and location, amount of dust removal, contamination of target surfaces, oper-  
588 ational duration, installation, and safety. While our analyses were qualitative, we reached  
589 the following findings. First, the electrostatic dust shielding technology has demonstrated  
590 its high dust removal capability. This technique has been demonstrated to remove dust ef-  
591 fectively and reduce its safety issues. Additional efforts may further overcome challenges in  
592 operational duration and installation. Second, in contrast to the electrostatic dust shielding  
593 technique, the attractive surface technique does not need installation and can flexibly be  
594 used to remove dust. This technique can be further improved by quantifying the amount  
595 of dust removal and operational duration. Finally, a combination of electron beams and  
596 plasma jets can enhance dust removal. This approach will improve its capability by adding  
597 further investigations for the contamination of target surfaces and safety. We also discussed a  
598 supporting system that loads dust particles so that the remediation techniques demonstrate  
599 dust removal efficiency. We conclude that further investigations on lab and spaceflight scales  
600 will advance dust remediation technologies for future lunar missions.

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## 606 **References**

- 607 [1] G. H. Heiken, et al., Lunar sourcebook (1991).
- 608 [2] M. Hirabayashi, et al., The Role of Breccia Lenses in Regolith Generation From the  
609 Formation of Small, Simple Craters: Application to the Apollo 15 Landing Site, *Journal*  
610 *of Geophysical Research: Planets* 123 (2018) 527–543. doi:10.1002/2017JE005377.
- 611 [3] Y.-H. Huang, et al., Heterogeneous impact transport on the Moon, *Journal of Geophys-*  
612 *ical Research: Planets* (2017) 1,158–1,180doi:10.1002/2016JE005160.
- 613 [4] C. M. Hartzell, et al., Payload Concepts for Investigations of Electrostatic Dust Motion  
614 on the Lunar Surface, *Acta Astronautica* Under review (2021).
- 615 [5] S. A. Wagner, The Apollo Experience Lessons Learned for Constellation Lunar Dust  
616 Management, Tech. Rep. NASA/TP-2006-213726 (2006).
- 617 [6] H. H. Schmitt, *Return to the Moon: Exploration, Enterprise, and Energy in the Human*  
618 *Settlement of Space*, Springer, 2006.
- 619 [7] A. Witze, Opportunity lost: NASA says goodbye to pioneering Mars rover, *Nature*  
620 (2019). doi:10.1038/d41586-019-00575-2.

- 621 [8] R. A. Yingst, et al., Dust cover on Curiosity's Mars Hand Lens Imager (MAHLI) cali-  
622 bration target: Implications for deposition and removal mechanisms, *Icarus* 351 (2020)  
623 113872. doi:10.1016/j.icarus.2020.113872.
- 624 [9] D. S. Lauretta, et al., The unexpected surface of asteroid (101955) Bennu, *Nature*  
625 568 (7750) (2019) 55–60. doi:10.1038/s41586-019-1033-6.
- 626 [10] S. Watanabe, et al., Hayabusa2 arrives at the carbonaceous asteroid 162173  
627 Ryugu-A spinning top-shaped rubble pile, *Science* 364 (6437) (2019) 268–272.  
628 doi:10.1126/science.aav8032.
- 629 [11] T. Morota, et al., Sample collection from asteroid (162173) Ryugu by Hayabusa2: Impli-  
630 cations for surface evolution, *Science* 368 (2020) 654–659. doi:10.1126/science.aaz6306.
- 631 [12] N. Afshar-Mohajer, et al., Review of dust transport and mitigation technologies in  
632 lunar and Martian atmospheres, *Advances in Space Research* 56 (6) (2015) 1222–1241.  
633 doi:10.1016/j.asr.2015.06.007.  
634 URL <http://dx.doi.org/10.1016/j.asr.2015.06.007>
- 635 [13] J. Aliberti, Design of a Device to Remove Lunar Dust from Space Suits for the Proposed  
636 Lunar Base, Tech. rep. (1990).
- 637 [14] K. Wood, Design of equipment for lunar dust removal, Tech. rep. (1991).  
638 doi:10.12681/eadd/1834.
- 639 [15] R. V. Peterson, C. W. Bowers, Contamination removal by CO<sub>2</sub> jet spray, in:  
640 Opt/ca/System Contamination: Effects, Measurement, Control 11, no. 1329, 1990, pp.  
641 72–85. doi:10.1117/12.22599.
- 642 [16] J. R. Gaier, et al., Evaluation of Surface Modification as a Lunar Dust Mitigation  
643 Strategy for Thermal Control Surfaces, in: 41st International Conference on Envi-  
644 ronmental Systems, 17-21 July 2011, Portland, Oregon, Vol. AIAA 2011-5183, 2011.  
645 doi:10.2514/6.2011-5183.
- 646 [17] S. Jacobs, et al., Lunar dust depositiion effects on the solar absorptance of thermal  
647 control materials, in: AIAA 6th Thermophysics Conferences, no. 71-459, 1971, pp. 0–7.
- 648 [18] J. R. Gaier, The Effects of Lunar Dust on EVA Systems During the Apollo Missions,  
649 Nasa/Tm-2005-213610/Rev1 (March) (2007) 1–16.
- 650 [19] J. R. Gaier, et al., Evaluation of surface modification as a lunar dust mitigation strategy  
651 for thermal control surfaces, 41st International Conference on Environmental Systems  
652 2011, ICES 2011 (December) (2011). doi:10.2514/6.2011-5183.
- 653 [20] J. R. Gaier, Interpretation of the Apollo 14 Thermal Degradation Sample experiment,  
654 *Icarus* 221 (1) (2012) 167–173. doi:10.1016/j.icarus.2012.07.002.  
655 URL <http://dx.doi.org/10.1016/j.icarus.2012.07.002>

- 656 [21] J. S. Halekas, et al., Lunar Prospector observations of the electrostatic potential of the  
657 lunar surface and its response to incident currents, *Journal of Geophysical Research: Space Physics* 113 (2008) A09102. doi:10.1029/2008JA013194.  
658
- 659 [22] J. E. Borovsky, G. Delzanno, Do Impulsive Solar-Energetic-Electron (SEE) Events Drive  
660 High-Voltage Charging Events on the Nightside of the Moon?, *frontiers in Astronomy and Space Sciences* 8 655333. doi:10.3389/fspas.2021.655333.  
661
- 662 [23] T. D. Glotch, et al., Formation of lunar swirls by magnetic field standoff of the solar  
663 wind, *Nature Communications* 6 (2015) 6,189. doi:10.1038/ncomms7189.
- 664 [24] C. Buhler, et al., Current state of the electrodynamic dust shield for mitigation, in:  
665 *Lunar and Planetary Science Conference*, no. 5027, 2020.
- 666 [25] S. Masuda, et al., Confinement and Transportation of Charged Aerosol Clouds  
667 via Electric Curtain, *Electrical Engineering in Japan* 92 (1) (1972) 9–18.  
668 doi:10.1002/eej.4390920106.
- 669 [26] S. Masuda, Y. Matsumoto, Theoretical characteristics of standing-wave electric curtains,  
670 *Electrical Engineering in Japan* 93 (1) (1973) 41–53. doi:10.1002/eej.4390930110.
- 671 [27] S. Masuda, T. Kamimura, Approximate methods for calculating a non-uniform traveling  
672 field, *Journal of Electrostatics* 1 (1975) 351–370. doi:10.1016/0304-3886(75)90030-3.
- 673 [28] F. B. Tatom, et al., Lunar dust degradation effects and remove/prevention concepts, in:  
674 *NASA Technical Report*, 1967, pp. TR-792-7-207A.
- 675 [29] C. Calle, et al., Dust particle removal by electrostatic and dielectrophoretic forces with  
676 applications to nasa exploration missions, in: *Proceedings of the ESA Annual Meeting on Electrostatics 2008*, 2008.  
677
- 678 [30] C. I. Calle, et al., Electrodynamic dust shield for surface exploration activities on the  
679 moon and Mars, *AIAA 57th International Astronautical Congress, IAC 2006* 3 (2006) 1851–1861. doi:10.2514/6.iac-06-a5.2.07.  
680
- 681 [31] C. I. Calle, et al., Particle removal by electrostatic and dielectrophoretic forces for dust  
682 control during lunar exploration missions, *Journal of Electrostatics* 67 (2-3) (2009) 89–  
683 92. doi:10.1016/j.elstat.2009.02.012.
- 684 [32] C. I. Calle, et al., Active dust control and mitigation technology for lu-  
685 nar and Martian exploration, *Acta Astronautica* 69 (11-12) (2011) 1082–1088.  
686 doi:10.1016/j.actaastro.2011.06.010.
- 687 [33] K. K. Manyapu, et al., Proof of concept demonstration of novel technolo-  
688 gies for lunar spacesuit dust mitigation, *Acta Astronautica* 137 (2017) 472–481.  
689 doi:10.1016/j.actaastro.2017.05.005.
- 690 [34] R. A. Sims, et al., Development of a transparent self-cleaning dust shield for solar panels,  
691 *Proceedings ESA-IEEE joint meeting on electrostatics* (1) (2003) 814–821.

- 692 [35] C. E. Johnson, et al., Effect of particle size distribution on the performance of electrody-  
693 namic screens, Conference Record - IAS Annual Meeting (IEEE Industry Applications  
694 Society) 1 (2005) 341–345. doi:10.1109/IAS.2005.1518330.
- 695 [36] H. Kawamoto, T. Miwa, Mitigation of lunar dust adhered to mechanical parts of  
696 equipment used for lunar exploration, Journal of Electrostatics 69 (4) (2011) 365–369.  
697 doi:10.1016/j.elstat.2011.04.015.
- 698 [37] Q. X. Sun, et al., Mechanism of dust removal by a standing wave electric cur-  
699 tain, Science China: Physics, Mechanics and Astronomy 55 (6) (2012) 1018–1025.  
700 doi:10.1007/s11433-012-4722-9.
- 701 [38] H. Kawamoto, N. Hara, Electrostatic Cleaning System for Removing Lunar Dust  
702 Adhering to Space Suits, Journal of Aerospace Engineering 24 (4) (2011) 442–444.  
703 doi:10.1061/(asce)as.1943-5525.0000084.
- 704 [39] B. Guo, et al., Electrodynamical dust shield performance under simulated operating con-  
705 ditions for solar energy applications, Solar Energy Materials and Solar Cells 185 (2018)  
706 80–85. doi:10.1016/j.solmat.2018.05.021.
- 707 [40] B. Guo, et al., Solar pv soiling mitigation by electrodynamic dust shield in field condi-  
708 tions, Solar Energy 188 (2019) 271–277. doi:10.1063/5.0053866.
- 709 [41] H. Kawamoto, B. Guo, Improvement of an electrostatic cleaning system for re-  
710 moval of dust from solar panels, Journal of Electrostatics 91 (2018) 28–33.  
711 doi:10.1016/j.elstat.2017.12.002.
- 712 [42] J. K. W. Chesnutt, et al., Numerical analysis of the effects of particle-particle interac-  
713 tions and particle size on the performance of an electrodynamic dust shield, Journal of  
714 Electrostatics 98 (2019) 58–68. doi:10.1016/j.elstat.2019.02.005.
- 715 [43] A. Sayyah, et al., An experimental study on the characterization of electric  
716 charge in electrostatic dust removal, Journal of Electrostatics 87 (2017) 173–179.  
717 doi:10.1016/j.elstat.2017.04.001.
- 718 [44] W. Javed, B. Guo, Effect of relative humidity on dust removal perfor-  
719 mance of electrodynamic dust field, Journal of Electrostatics 105 (2020) 103434.  
720 doi:10.1016/j.elstat.2020.103434.
- 721 [45] G. Y. Kramer, et al., M<sup>3</sup> spectral analysis of lunar swirls and the link between optical  
722 maturation and surface hydroxyl formation at magnetic anomalies, Journal of Geophys-  
723 ical Research: Planets (116) (2011) E00G18. doi:10.1029/2010JE003729.
- 724 [46] L. C. Cheek, et al., The distribution and purity of anorthosite across the Orientale  
725 basin: New perspectives from MoonMineralogy Mapper data, Journal of Geophysical  
726 Research: Planets (118) (2013) 1,805–1,820. doi:10.1002/jgre.20126.2013.

- 727 [47] D. P. Moriarty, C. M. Pieters, The Character of South Pole-Aitken Basin: Patterns of  
728 Surface and Subsurface Composition, *Journal of Geophysical Research: Planets* (123)  
729 (2018) 729–747. doi:10.1002/2017/JE005364.
- 730 [48] C. Calle, et al., Integration of the electrodynamic dust shield on a lunar habitat demon-  
731 stration unit, in: *Proceedings of the ESA Annual Meeting on Electrostatics 2010*, 2010.
- 732 [49] H. Kawamoto, S. Hashime, Practical performance of an electrostatic cleaning system  
733 for removal of lunar dust from optical elements utilizing electrostatic traveling wave,  
734 *Journal of Electrostatics* 94 (2018) 38–43. doi:10.1016/j.elstat.2018.05.004.
- 735 [50] P. Mackey, et al., Electrodynamic dust shield for space applications, in: *Proceedings of*  
736 *the ASCE Conference on Engineering, Science, Construction and Operations in Chal-*  
737 *lenging Environments*, 2016, pp. 539–545.
- 738 [51] J. Schwan, et al., The charge state of electrostatically transported dust  
739 on regolith surfaces, *Geophysical Research Letters* 44 (2017) 2017GL072909.  
740 doi:10.1002/2017GL072909.
- 741 [52] D. Carter, C. Hartzell, Experimental methodology for measuring in-vacuum granular tri-  
742 bocharging, *Review of Scientific Instruments* 90 (2019) 125105. doi:10.1063/1.5111983.
- 743 [53] S. I. Popel, et al., Dusty Plasma at the Surface of the Moon, *Solar System Research* 47  
744 (2013) 419–429. doi:10.1134/S0038094613060063.
- 745 [54] T. Jackson, et al., Discharging of roving objects in the lunar polar regions, *Journal of*  
746 *Spacecraft and Rockets* 48 (4) (2011) 700–703.
- 747 [55] T. M. Flanagan, J. Goree, Dust release from surfaces exposed to plasma, *Physics of*  
748 *Plasmas* 13 (12) (2006) 123504. doi:10.1063/1.2401155.  
749 URL <http://aip.scitation.org/doi/10.1063/1.2401155>
- 750 [56] B. Farr, et al., Dust mitigation technology for lunar exploration utilizing an electron  
751 beam, *Acta Astronautica* 177 (2020) 405–409. doi:10.1016/j.actaastro.2020.08.003.  
752 URL <https://linkinghub.elsevier.com/retrieve/pii/S0094576520304902>
- 753 [57] C. M. Ticos, et al., A pulsed ‘plasma broom’ for dusting off surfaces on Mars, *New*  
754 *Journal of Physics* 19 (6) (2017) 063006. doi:10.1088/1367-2630/aa60e5.  
755 URL <https://iopscience.iop.org/article/10.1088/1367-2630/aa60e5>
- 756 [58] E. C. Whipple, Potentials of surfaces in space, *Reports on Progress in Physics* 44 (11)  
757 (1981) 1197–1250. doi:10.1088/0034-4885/44/11/002.
- 758 [59] M. Keidar, et al., Electrical discharge in the Teflon cavity of a coaxial pulsed  
759 plasma thruster, *IEEE Transactions on Plasma Science* 28 (2) (2000) 376–385.  
760 doi:10.1109/27.848096.  
761 URL <http://ieeexplore.ieee.org/document/848096/>



- 762 [60] S. Mazouffre, Electric propulsion for satellites and spacecraft: established technologies  
763 and novel approaches, *Plasma Sources Science and Technology* 25 (3) (2016) 033002.  
764 doi:10.1088/0963-0252/25/3/033002.  
765 URL <https://iopscience.iop.org/article/10.1088/0963-0252/25/3/033002>
- 766 [61] J. Kolbeck, A. Anders, I. I. Beilis, M. Keidar, Micro-propulsion based on vacuum arcs,  
767 *Journal of Applied Physics* 125 (22) (2019) 220902. doi:10.1063/1.5081096.  
768 URL <http://aip.scitation.org/doi/10.1063/1.5081096>
- 769 [62] R. L. Burton, P. J. Turchi, Pulsed Plasma Thruster, *Journal of Propulsion and Power*  
770 14 (5) (1998) 716–735. doi:10.2514/2.5334.  
771 URL <https://arc.aiaa.org/doi/10.2514/2.5334>
- 772 [63] C. D. Rayburn, et al., Pulsed Plasma Thruster System for Microsatellites, *Journal of*  
773 *Spacecraft and Rockets* 42 (1) (2005) 161–170. doi:10.2514/1.15422.  
774 URL <https://arc.aiaa.org/doi/10.2514/1.15422>
- 775 [64] N. Murdoch, I. Avila Martinez, C. Sunday, E. Zenou, O. Cherrier, A. Cadu, Y. Gourinat,  
776 An experimental study of low-velocity impacts into granular material in re-  
777 duced gravity, *Monthly Notices of the Royal Astronomical Society* 468 (2) 1259–1272.  
778 doi:10.1093/mnras/stw3391.
- 779 [65] B. J. O’Brien, M. Hollick, Sunrise-driven movements of dust on the moon: Apollo  
780 12 ground-truth measurements, *Planetary and Space Science* 119 (2015) 194–199.  
781 doi:<https://doi.org/10.1016/j.pss.2015.09.018>.
- 782 [66] Martin Vibration Systems and Solutions, Catalog for Micro Series Electric Vibrators,  
783 <https://www.shake-it.com/app/uploads/2013/02/MicroSeries-2-1-unlocked.pdf>.

# Highlights

## **Electrostatic dust remediation for future exploration of the Moon**

M. Hirabayashi, C. M. Hartzell, P. M. Bellan, D. Bodewits, G. L. Delzanno, T. W. Hyde, U. Konopka, E. Thomas, Jr., H. M. Thomas, I. Hahn, U. E. Israelsson

- We assess three dust mitigation technologies for in-situ lunar explorations.
- Six operational factors are considered to qualitatively assess their maturity.
- Further assessment sheds light on how mitigation technologies work on the Moon.
- Operation duration and safety are key to improving dust mitigation technologies.
- We also introduce a dust loading device that supplies dust to a testbed in situ.